# Monthly LabAdviser update: 12/1 2018

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| Updated Subject | Contributor | Link to the updated pages |
| **SiO etch**  New etch results for SiO etch has been included. | **Majken Becker @danchip** | [Etch/Wet\_Silicon\_Oxide\_Etch\_(BHF)](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Etch/Wet_Silicon_Oxide_Etch_(BHF)) |
| **Aligner: Maskless 01**   * New equipment page/section * Subpage with information on substrate positioning and details on aligning. | **Thomas Anhøj @danchip** | [Lithography/UVExposure#Aligner:\_Maskless\_01](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Lithography/UVExposure#Aligner:_Maskless_01)  [Lithography/Aligners/Aligner:\_Maskless\_01\_processing](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Lithography/Aligners/Aligner:_Maskless_01_processing) |
| **Plasma Asher Pico 2**  The plasma asher in Packlab has now got an equipment page in LabAdviser | **Jesper Hanberg @danchip.dtu.dk** | [Back-end\_processing/Packlab\_Plasma\_Asher\_Pico\_2](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Back-end_processing/Packlab_Plasma_Asher_Pico_2) |
| **Survey**  Results from the November 2017 survey have been uploaded to LabAdviser including comments from the management. | **Mette Noer @danchip** | [Surveys\_and\_statistics#Surveys](http://labadviser.danchip.dtu.dk/index.php/Surveys_and_statistics#Surveys)  [November\_2017\_Survey](http://labadviser.danchip.dtu.dk/index.php/November_2017_Survey) |
| **AFM**  Work function measurement – how to calibrate | **Berit Herstrøm @danchip** | [AFM:\_Atomic\_Force\_Microscopy/KPFM](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Characterization/AFM:_Atomic_Force_Microscopy/KPFM) |

# Equipment Manuals updated in LabManager:

As an approved user on a piece of equipment you have to make sure you have read and understood the latest version of the manual before using the equipment.

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|  | **Manual for Wafer Cleaning** |
|  | **Manual for Mask Cleaning** |
|  | **Manual for RTP Jipelec** |
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|  | **Manual for Leitz Medilux optical microscope** |
|  | **Manual for Leica S8 APO optical microscope** |
|  | **Manual for Zeiss Jenatech (particle measturements) optical microscope** |
|  | **Manual for Zeiss Jenatech (Strain) optical microscope** |
|  | **Manual for Nikon ME 600 optical microscope** |
|  | **Manual for Nikon ECLIPSE L200 (2) optical microscope** |
| http://d4.danchip.dtu.dk/D4Doc/res/menu/user_bullet.gif | **Manual for Zeiss Axiotron 2 optical microscope** |
| http://d4.danchip.dtu.dk/D4Doc/res/menu/user_bullet.gif | **Manual for III-V Plassys RIE** |